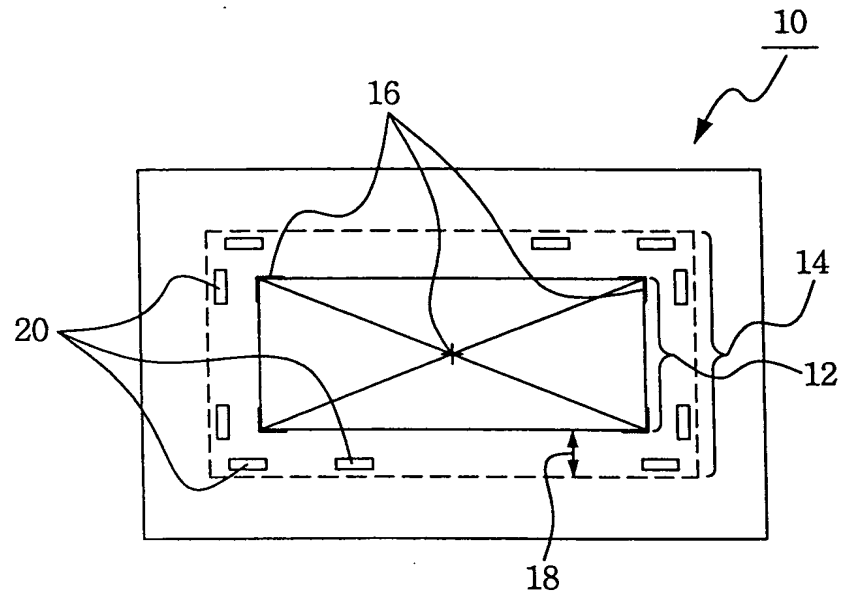


METHOD OF DESIGNING AND MANUFACTURING RETICLES FOR USE IN A
PHOTOLITHOGRAPHIC PROCESS

Application No. [NEW] – Attorney Docket No. SEC.1090

Inventor: Won-Woong CHOI

FIG.1(PRIOR ART)

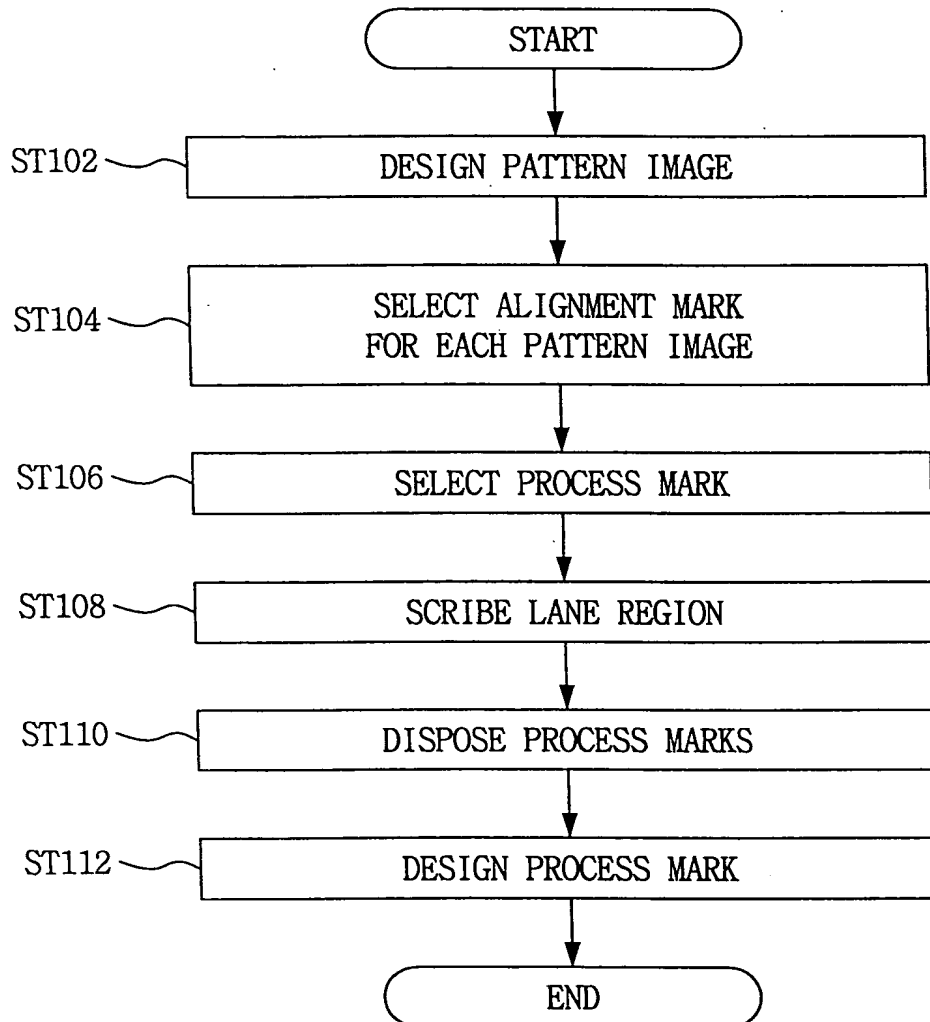


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FIG.2(PRIOR ART)

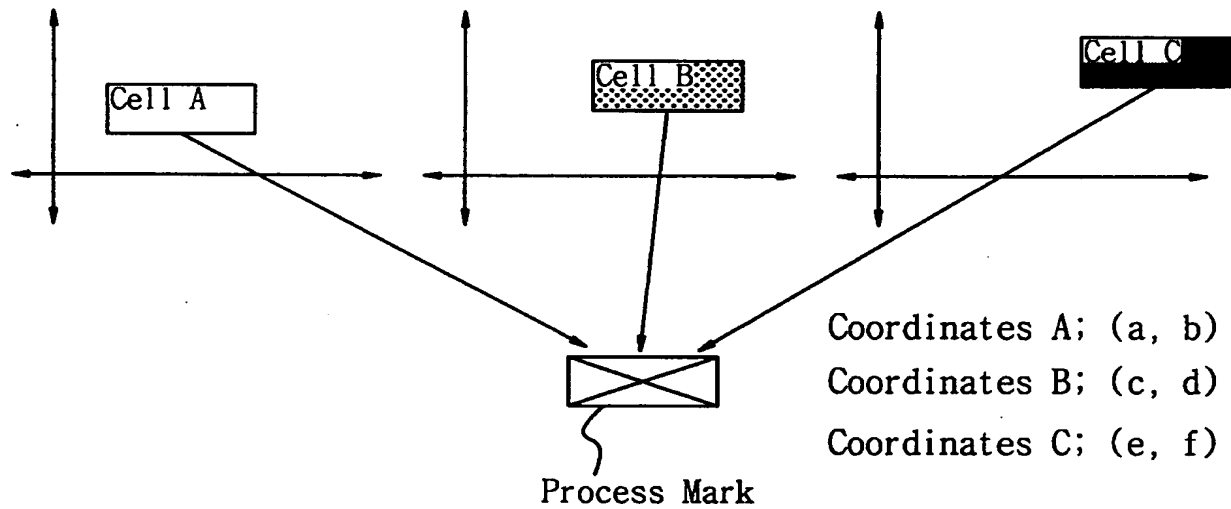


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FIG.3(PRIOR ART)

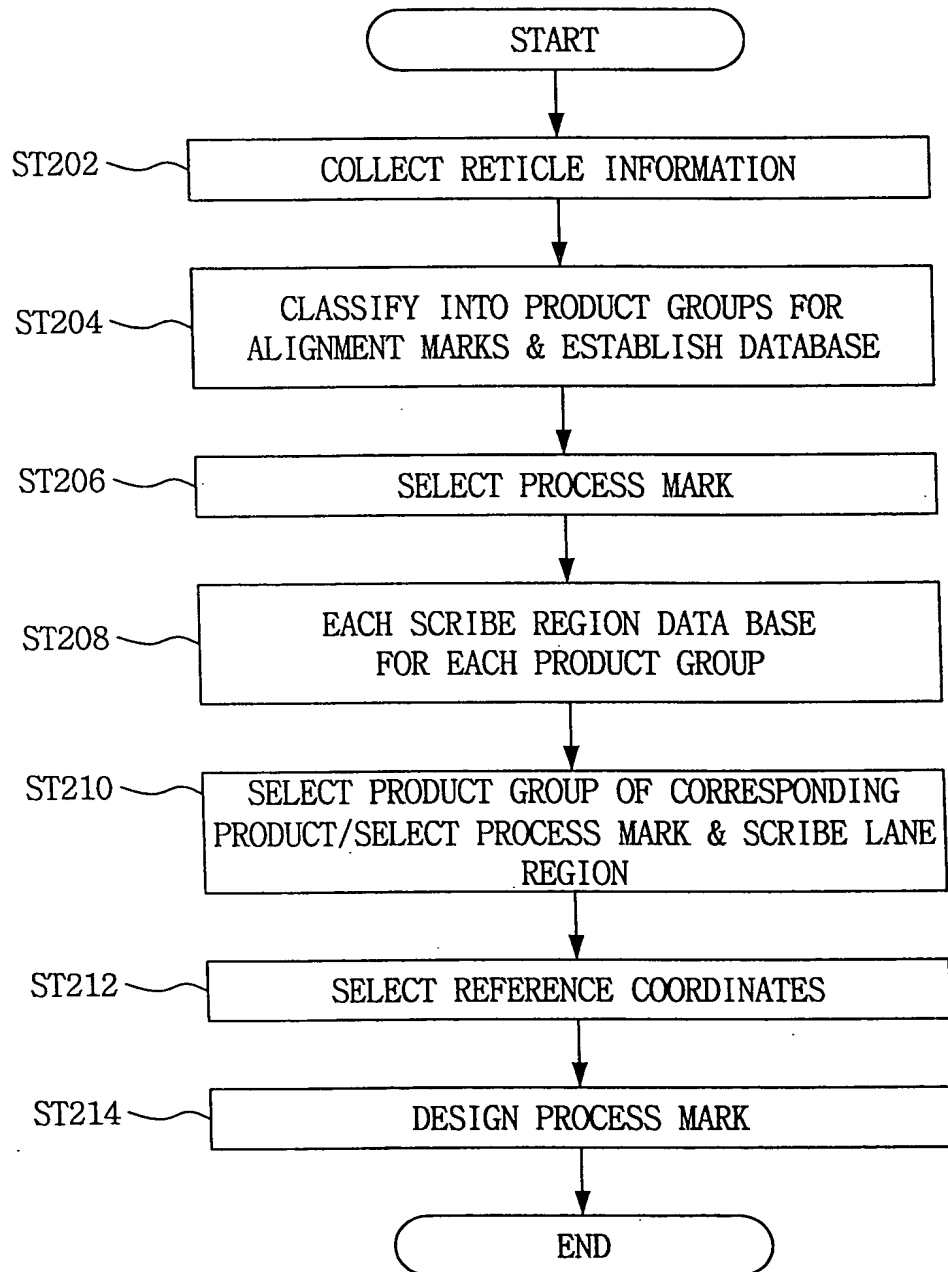


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FIG. 4

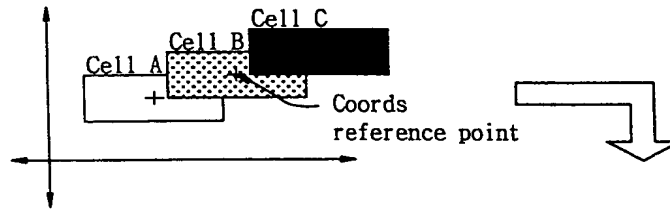


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FIG. 5



	X	Y
Cell A	a	b
Cell B	c	d
Cell C	e	f